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APPLICANTS

Jennifer Wang, Redondo Beach, CA;

** CONTINUING DATA ***** NONE LU

** FOREIGN APPLICATIONS ***** NONE LU

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 05/11/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
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Verified and Acknowledged
 Examiner's Signature: *[Signature]* Initials: *LU*

ADDRESS
 LaRiviere, Grubman & Payne, LLP
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 93942

TITLE
 Method of dry plasma etching semiconductor materials

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